



Docket No.: 50090-250

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: **RESPONSE UNDER 37 CFR 1.116**  
: **EXPEDITED PROCEDURE**

Kimio HAGI

Application No.: 09/732,891

: Group Art Unit: 2836

Filed: December 11, 2000

: Examiner: Isabel Rodriguez

For: ELECTROSTATIC CHUCKING SYSTEM, AND APPARATUS AND  
METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE  
USING THE ELECTROSTATIC CHUCKING SYSTEM

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Mail Stop RCE/AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Final Office Action dated March 27, 2003, pursuant to the provisions of 37 C.F.R. § 1.116. Please amend the above-identified application as follows. The claims are presented in the revised amendment format described in the Pre-OG Notice dated January 31, 2003, regarding waiver of the current provisions of 37 C.F.R. §§ 1.121(a)-1.121(d).

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JUN 18 2003  
TECHNOLOGY CENTER 2800

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T.Bell.  
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